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Bib Data Sheet

**CONFIRMATION NO. 5269**

SERIAL NUMBER 10/603,306	FILING DATE 06/25/2003  RULE	CLASS 438	GROUP ART UNIT 2813	ATTORNEY DOCKET NO. CU-3271 RJS
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## \*\* CONTINUING DATA \*\*\*\*\*

TSP/None

## \*\* FOREIGN APPLICATIONS \*\*\*\*\*

REPUBLIC OF KOREA 2002-78659 12/11/2002

TSP/Yes

## IF REQUIRED, FOREIGN FILING LICENSE GRANTED

\*\* 09/17/2003

Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR	SHEETS	TOTAL	INDEPENDENT
35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance	COUNTRY	DRAWING	CLAIMS	CLAIMS
Verified and Acknowledged Examiner's Signature: <u>[Signature]</u> Initials: <u>TSP</u>	KOREA, REPUBLIC OF	3	16	1

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## TITLE

Method for forming capacitor of semiconductor device

FILING FEE  RECEIVED 750	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue ) <input type="checkbox"/> Other _____
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